

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 2822
Koichiro TANAKA et al.) Examiner: Mary A. Wilczewski
Serial No. 10/749,505)
Filed: January 2, 2004)
For: LASER IRRADIATION METHOD,)
METHOD FOR MANUFACTURING)
SEMICONDUCTOR DEVICE, AND)
LASER IRRADIATION SYSTEM)

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OFFICE OF PETITIONS

PETITION TO WITHDRAW FROM ISSUE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby petitions that the subject application be withdrawn from issue to permit consideration of an Information Disclosure Statement under 37 CFR 1.97 (submitted herewith) and a Request for Continued Examination (RCE) (also submitted herewith).

Also submitted herewith is the requisite fee of \$130.00 set forth in 37 CFR 1.17(i).

In view of the foregoing, it is urged that this petition is in order and, accordingly, a prompt grant thereof is requested.

The Commissioner is hereby authorized to charge any fees which may be further required in this application, except the issue fee, or credit any overpayment to Deposit

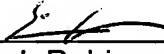
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Account No. 50-2280, under the above order number. A duplicate of this sheet is attached.

Respectfully submitted,



Eric J. Robinson
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U.S. SERIAL NO. 10/749,505

FILED: JANUARY 2, 2004

FOR: LASER IRRADIATION METHOD, METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE, AND LASER IRRADIATION SYSTEM

KOICHIRO TANAKA ET AL.

DOCKET NO.: 0756-7244

**SPECIAL PROCEDURES
SUBMISSION**

**PETITION TO WITHDRAW FROM
ISSUE**

DELIVER TO:

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TO 571-434-9499